

**DECLARATION FOR PATENT APPLICATION**

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name.

I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled THIN FILM TRANSISTOR AND METHOD OF MAKING SAME

the specification of which is attached hereto unless the following box is checked:

☒ was filed on August 26, 1997 as United States Application Number 08/918,119

I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by any amendment referred to above.

I acknowledge the duty to disclose information which is material to patentability as defined in 37 CFR § 1.56.

I hereby claim foreign priority benefits under 35 U.S.C. § 119(a)-(d) or § 365(b) of any foreign application(s) for patent or inventor's certificate, or § 365(a) of any PCT International application which designated at least one country other than the United States, listed below and have also identified below any foreign application for patent or inventor's certificate, or PCT International application having a filing date before that of the application on which priority is claimed.

<u>Prior Foreign Application(s)</u>	<u>Priority Date</u>	<u>Priority Claimed</u>	
		Yes No	
<u>97-07010</u>	<u>KOREA</u>	<u>March 4, 1997</u>	<input checked="" type="checkbox"/> <input type="checkbox"/>
(Number)	(Country) (PCT)	(Day/Month/Year Filed)	

I hereby claim the benefit under 35 U.S.C. § 119(e) of any United States provisional application(s) listed below.

\_\_\_\_\_  
(Application Number)

\_\_\_\_\_  
(Filing Date)

\_\_\_\_\_  
(Application Number)

\_\_\_\_\_  
(Filing Date)

I hereby claim the benefit under 35 U.S.C. § 120 of any United States application(s), or § 365(c) of any PCT International application designating the United States, listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States or PCT International application in the manner provided by the first paragraph of 35 U.S.C. § 112, I acknowledge the duty to disclose information which is material to patentability as defined in 37 CFR § 1.56 which became available between the filing date of the prior application and the national or PCT International filing date of this application.

\_\_\_\_\_  
(Application Number)

\_\_\_\_\_  
(Filing Date)

\_\_\_\_\_  
(Status -- patented, pending, abandoned)

\_\_\_\_\_  
(Application Number)

\_\_\_\_\_  
(Filing Date)

\_\_\_\_\_  
(Status -- patented, pending, abandoned)

I hereby appoint the following attorney(s) and/or agent(s) to prosecute this application and to transact all business in the Patent and Trademark Office connected therewith:

Albert L. Jacobs, Jr. Reg. No. 22,211  
Jesse D. Reingold Reg. No. 20,461  
Adam B. Landa Reg. No. 35,236

Gerard F. Diebner Reg. No. 31,345  
Israel Nissenbaum Reg. No. 27,582  
Joseph R. Keating Reg. No. 37,368  
Philip M. Weiss Reg. No. 34,751

Address all correspondence to: Joseph R. Keating, Esq.  
Intellectual Property Group  
Graham & James LLP  
885 Third Avenue  
New York, New York 10022  
(212) 848-1000

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

Full name of first inventor (given name, family name) Byung-Chul AHN

Inventor's signature

Byung Chul AHN

Date

Feb/9/1998

Residence Kumi-shi, Kyungsangbuk-do, KOREA

Citizenship KOREA

Post Office Address c/o LG Electronics Inc., 20 Yoido-dong, Youngdungpo-ku, Seoul, KOREA

Full name of first inventor (given name, family name) Hyun-Sik SEO

Inventor's signature

Hyun Sik Seo

Date

Feb/18/1998

Residence Anyang-shi, Kyungki-do, KOREA

Citizenship KOREA

Post Office Address c/o LG Electronics Inc., 20 Yoido-dong, Youngdungpo-ku, Seoul, KOREA